

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of:

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DEC 08, 2003

TC 1700

Applicant(s): Bin Yu et al.

Serial No: 10/044,493

Filing Date: January 11, 2002

Title: **SEMICONDUCTOR DEVICE WITH SILICIDE SOURCE/DRAIN AND HIGH-K DIELECTRIC**

Examiner: Kevin V. Quinto

Art Unit: 2826

Docket No. G0615

Confirmation No. 9266

REPLY TO OFFICE ACTION DATED SEPTEMBER 3, 2003

MS Non-Fee Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

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 TECHNOLOGY CENTER 2800

Sir:

Favorable reconsideration of the above-referenced application is respectfully requested in view of the following part(s) of this reply:

Amendments to the Claims

Remarks

Enclosures: ☐ Check in the amount of \$
☐ Petition for Extension of Time
☐ Information Disclosure Statement
☒ Interview Request Form

In the event any fee or additional fee is due in connection with the filing of this paper, the Commissioner is authorized to charge those fees to our Deposit Account No. 18-0988 (under the above Docket Number). In the event an extension of time is needed to make the filing of this paper timely and no separate petition is attached, please consider this a petition for the requisite extension and charge the fee to our Deposit Account No. 18-0988 (under the above Docket Number).